



5조

Alignment Key 정렬 자동화



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팀원 소개



조장
정현철



조원
전홍의



조원
박인하



조원
이호림



조원
정성훈



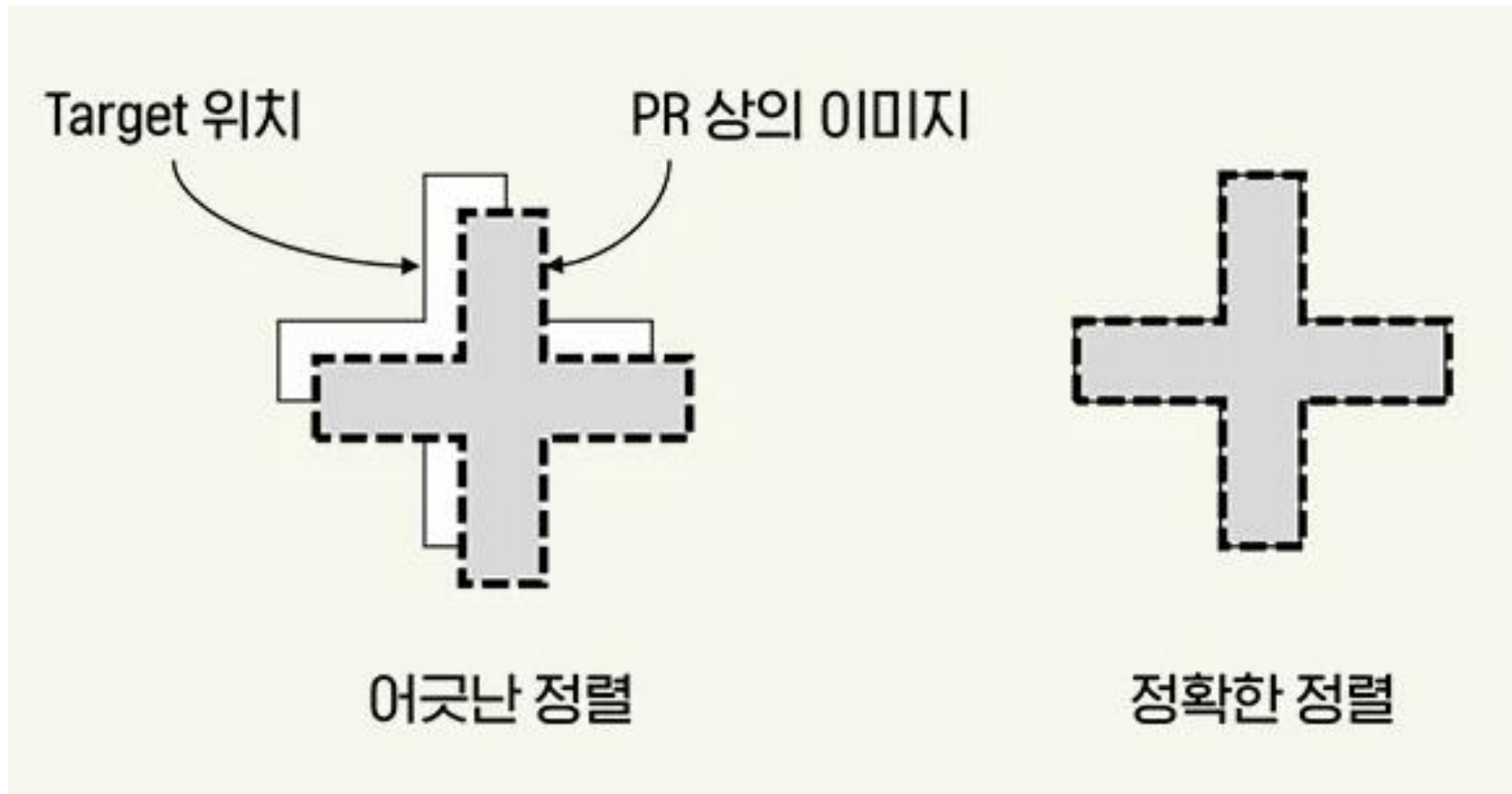
조원
조호준

프로젝트 주제

〈반도체 Align Key 정렬 자동화〉

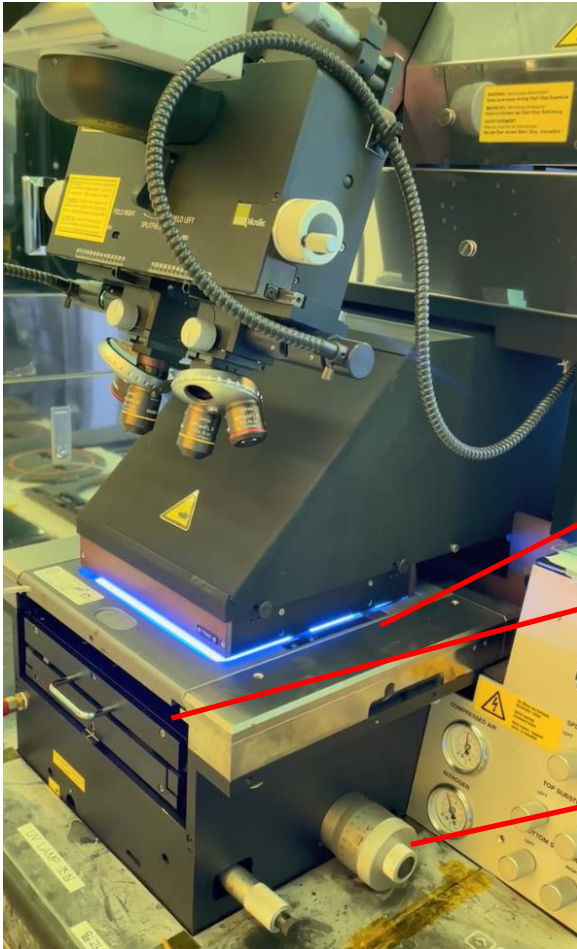
Alignment Key 정렬의 중요성

Alignment Key?



기존의 문제점

수동 정렬



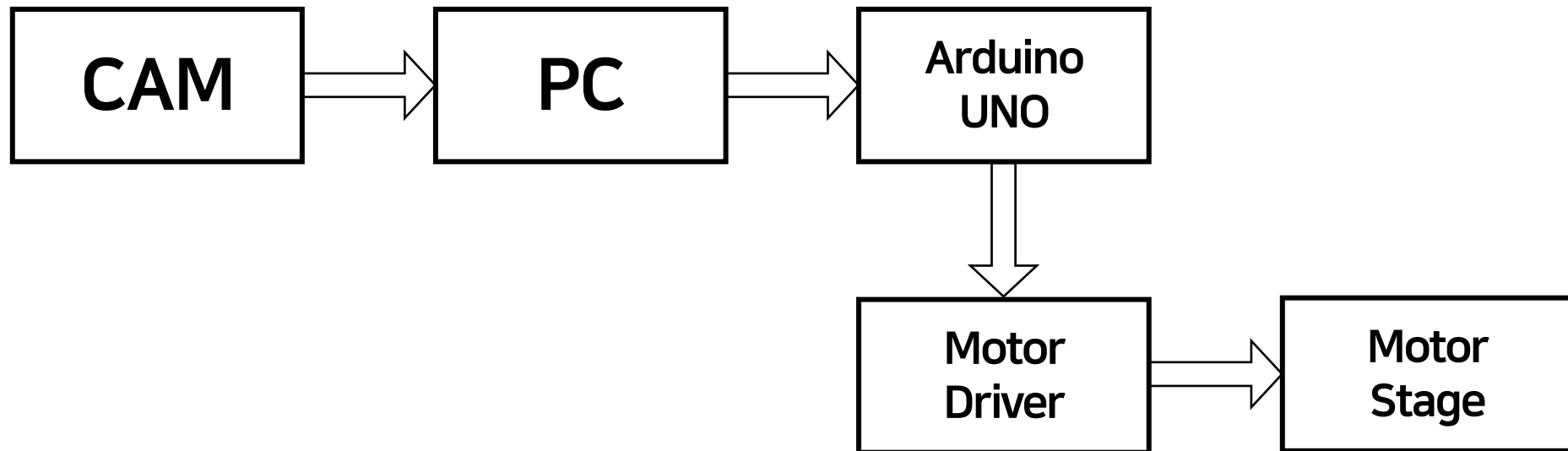
Photomask Holder

Wafer Holder

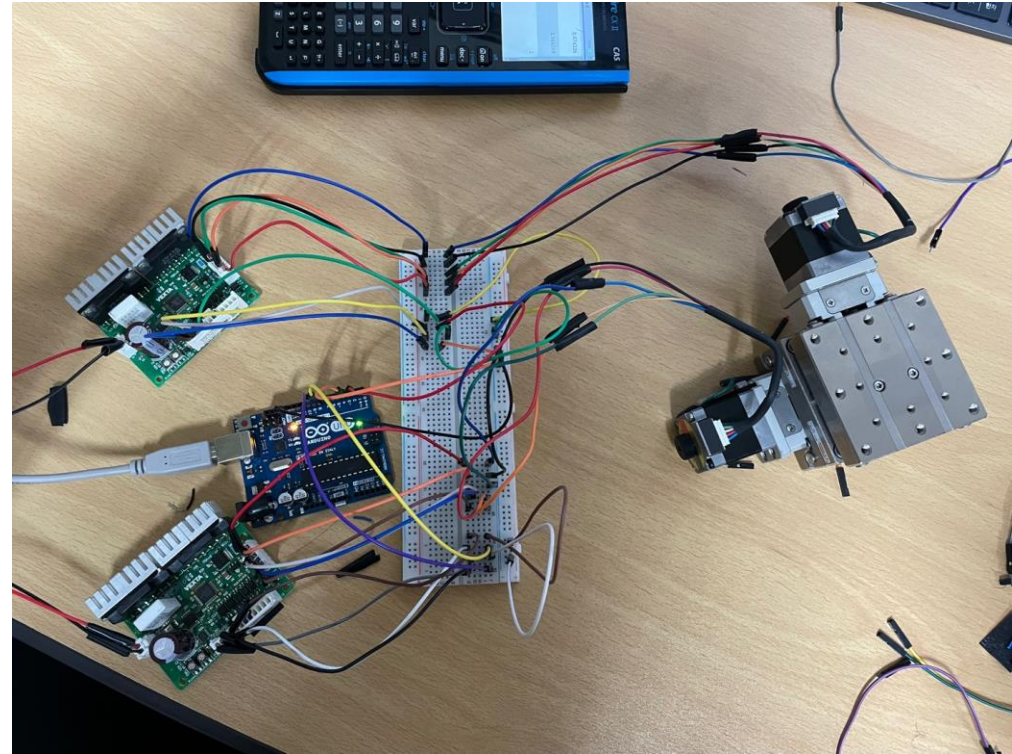
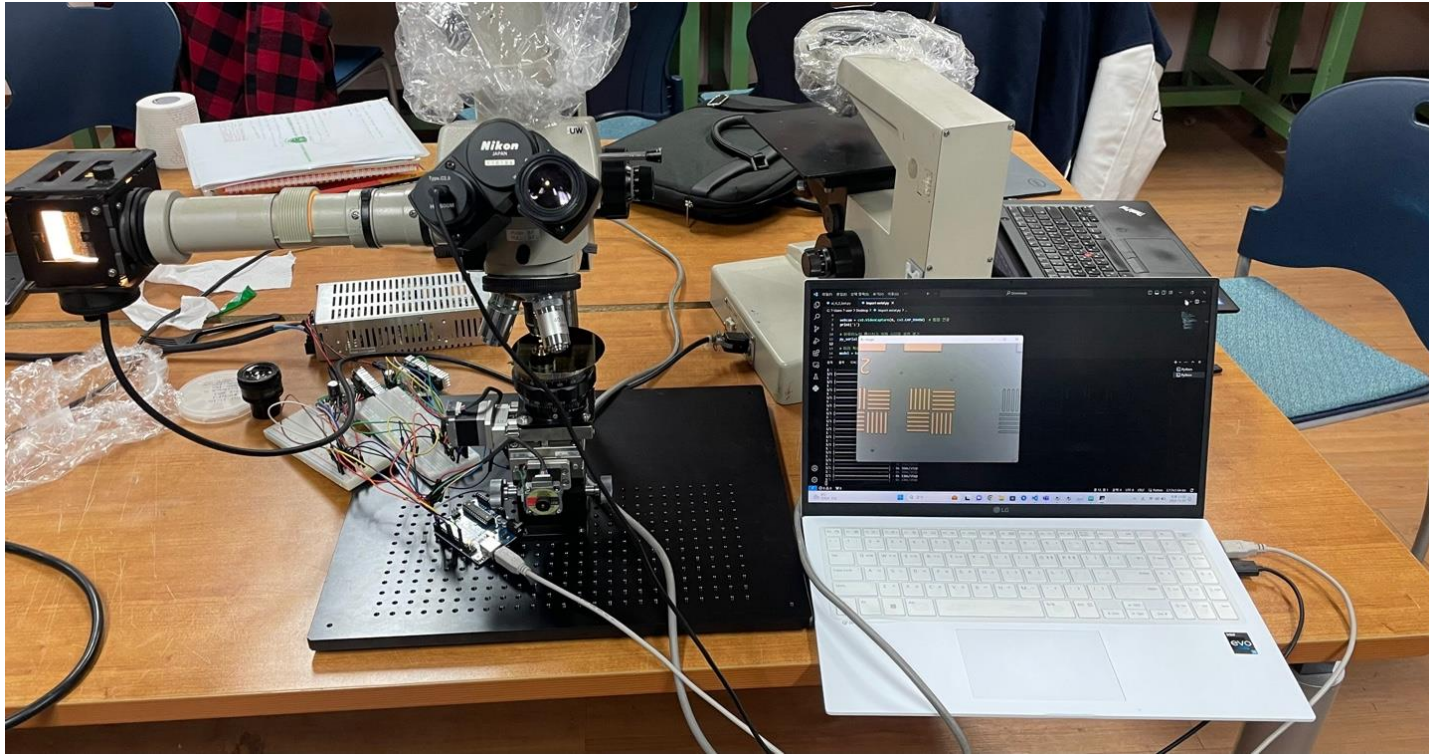
Manual Stage

- Manual Stage for Photomask-to-Wafer Alignment
- Alignment verification through an optical microscope

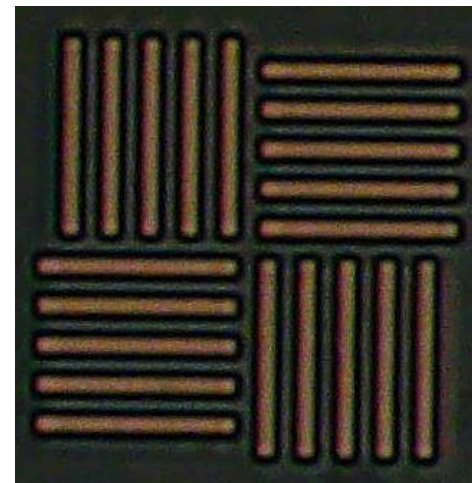
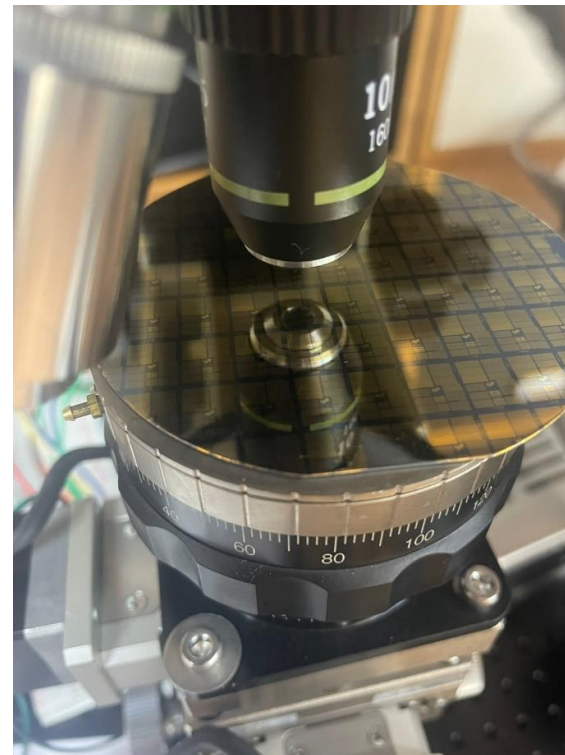
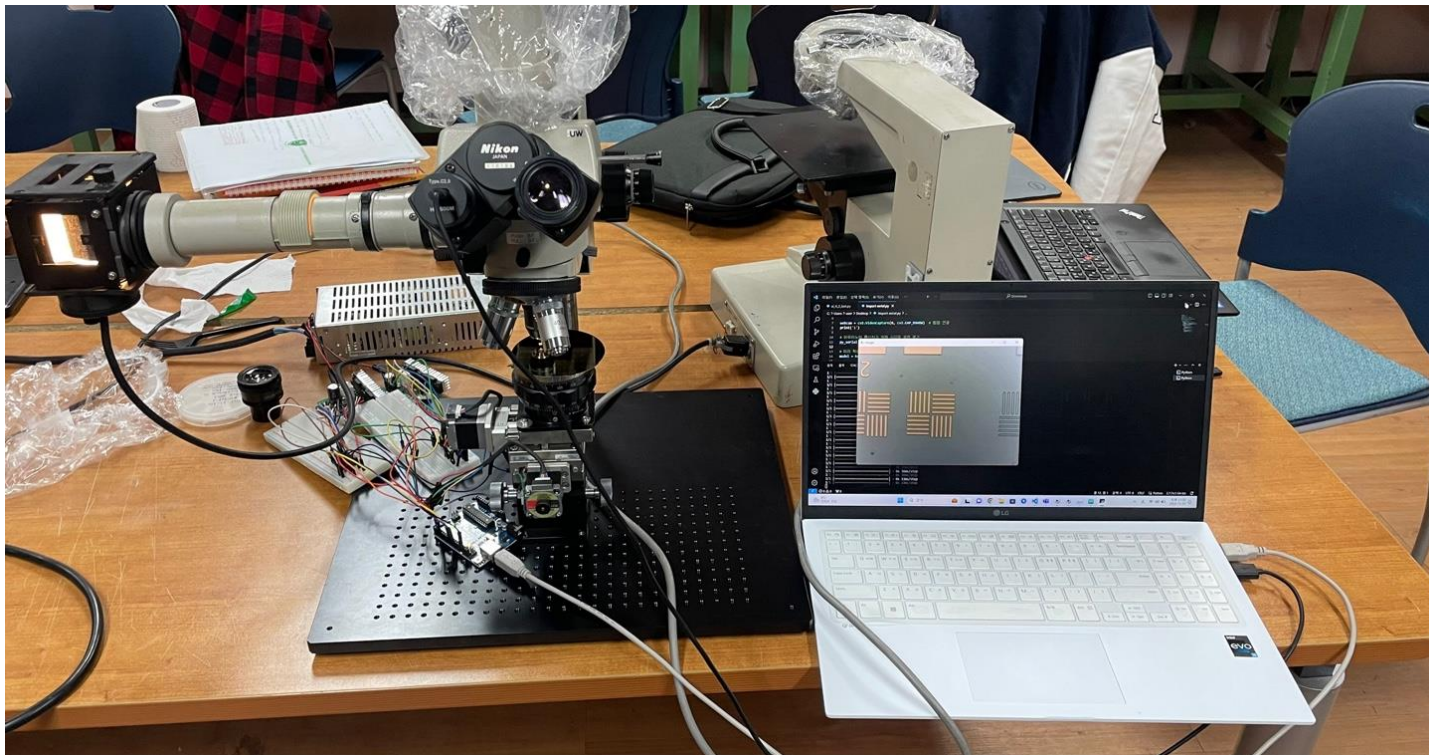
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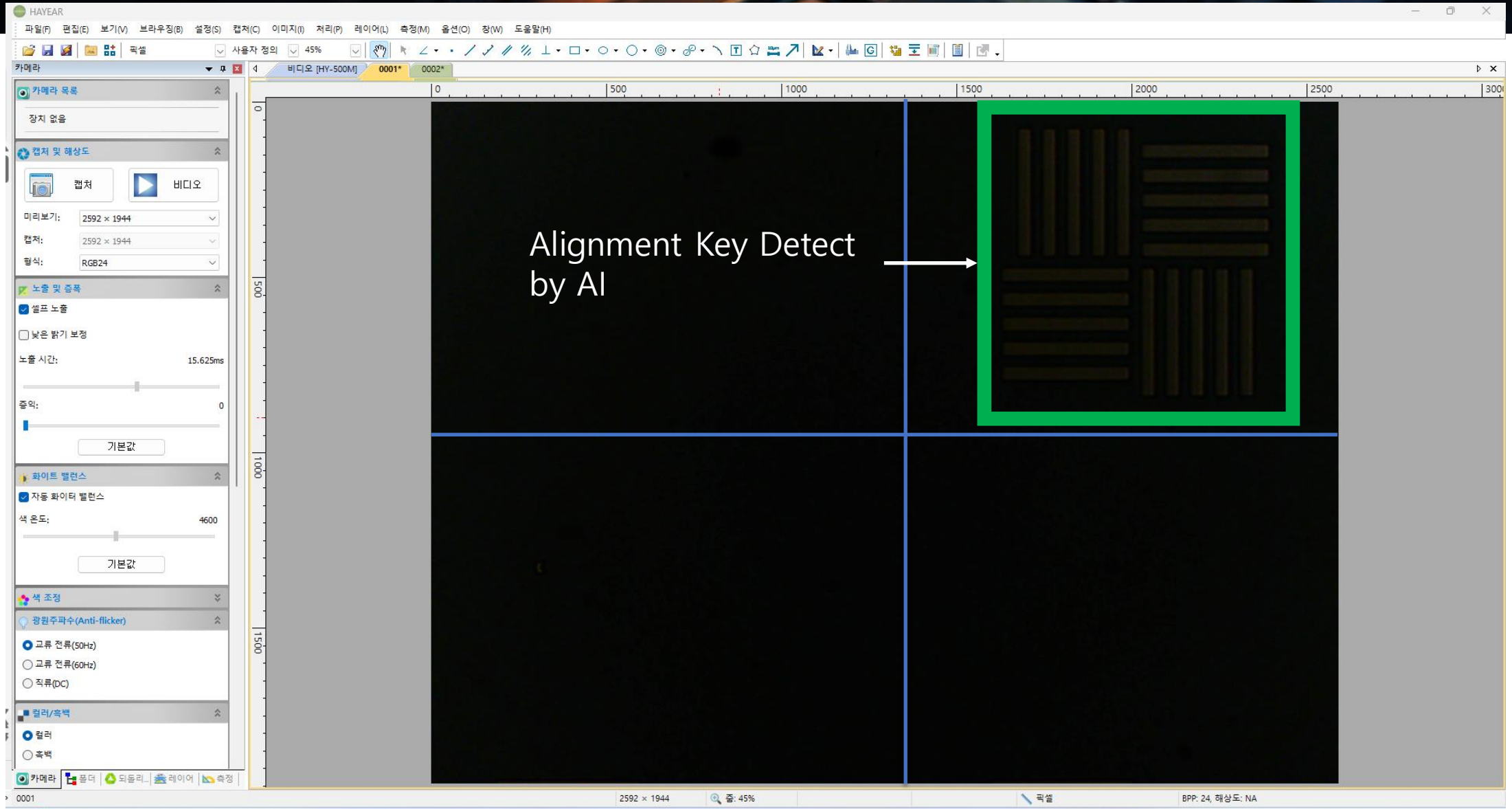
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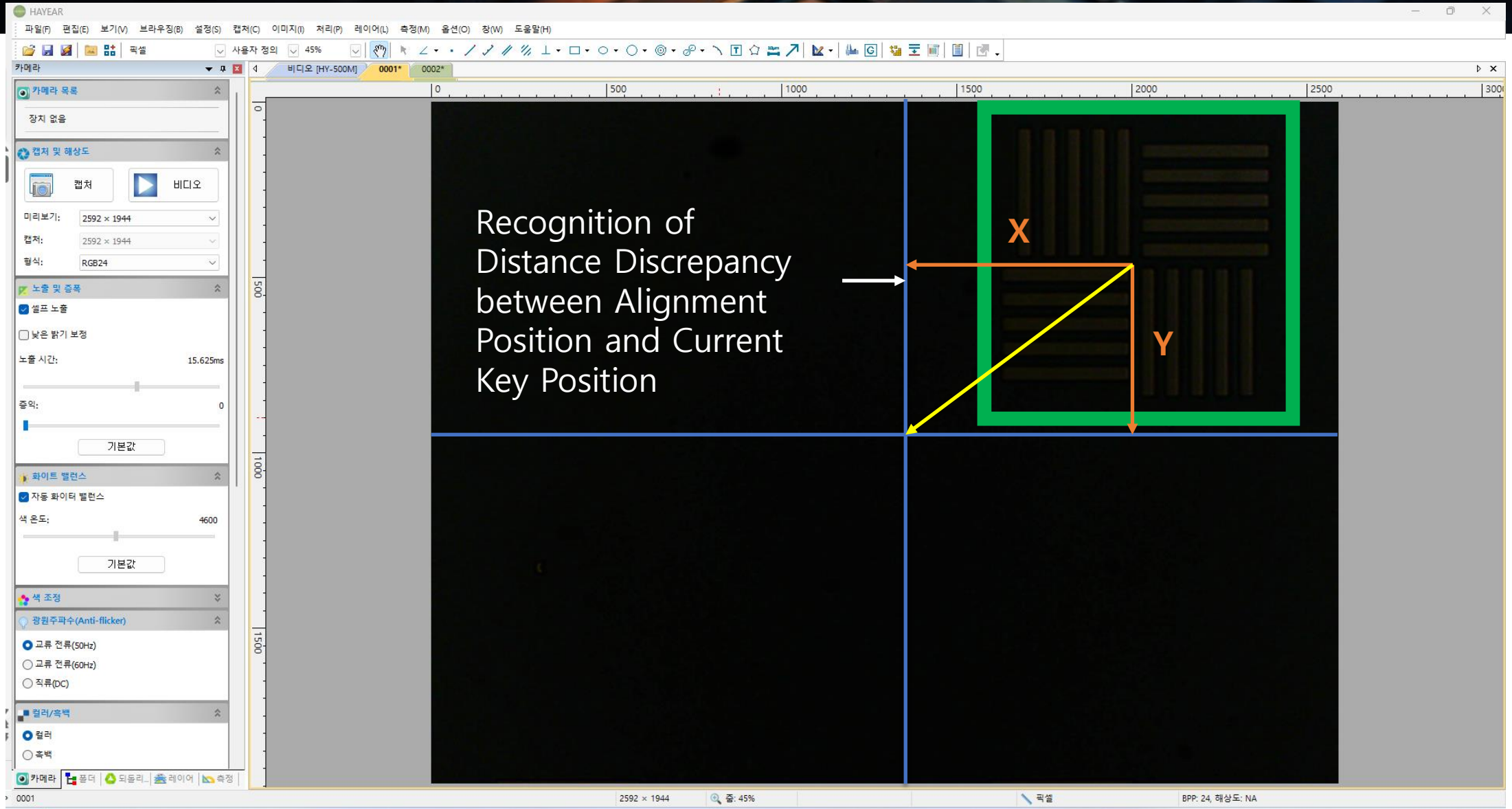
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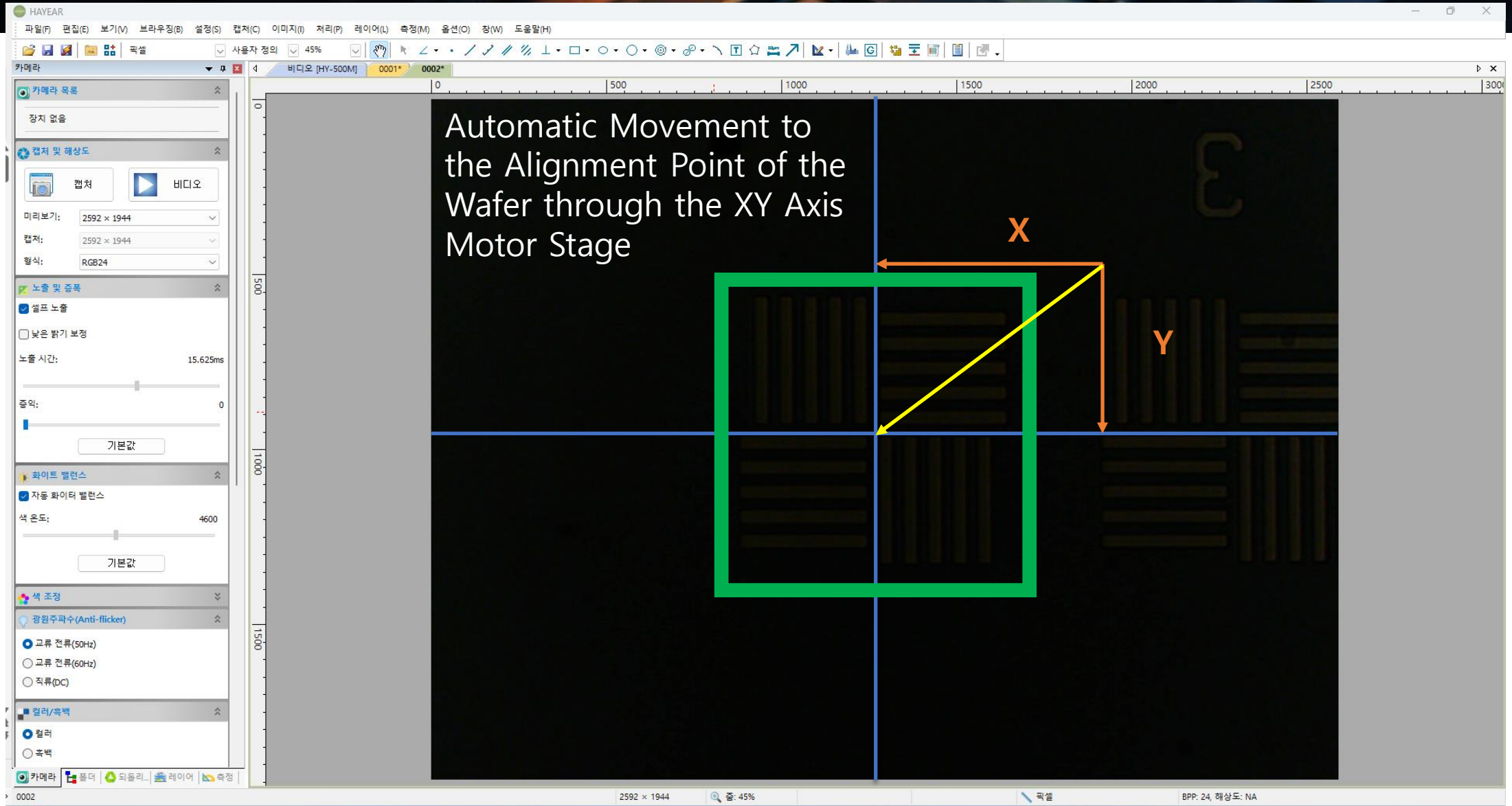
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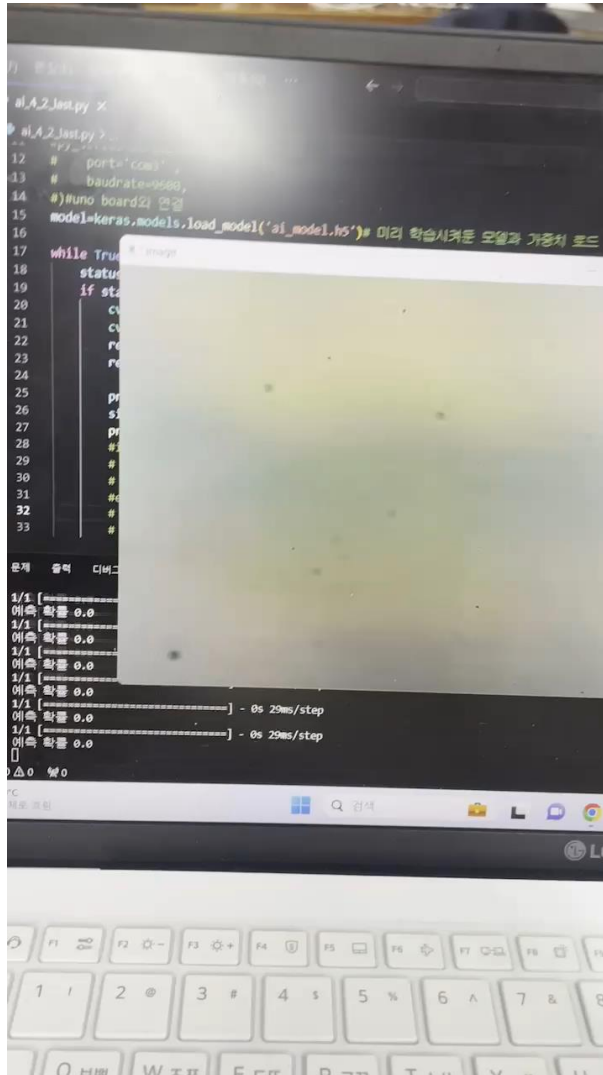


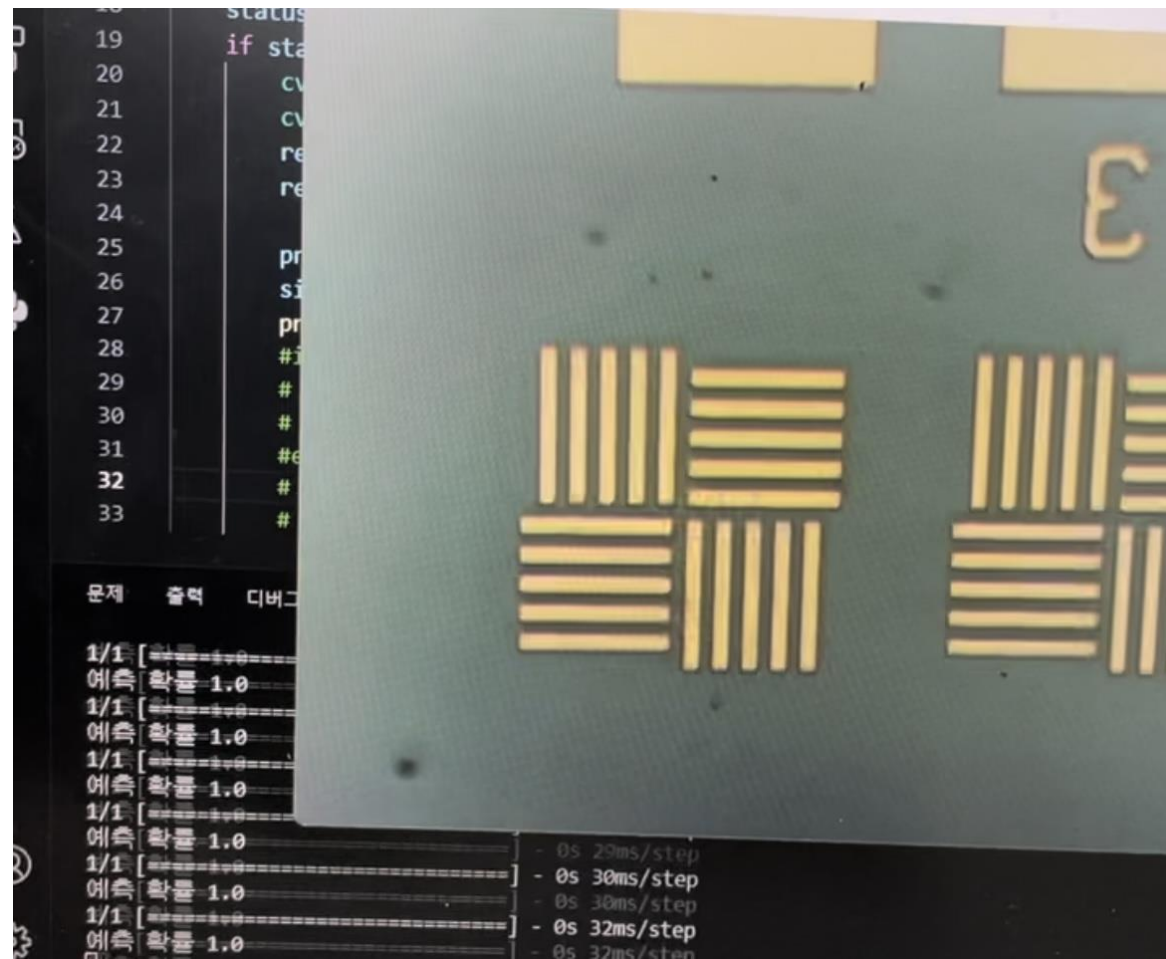
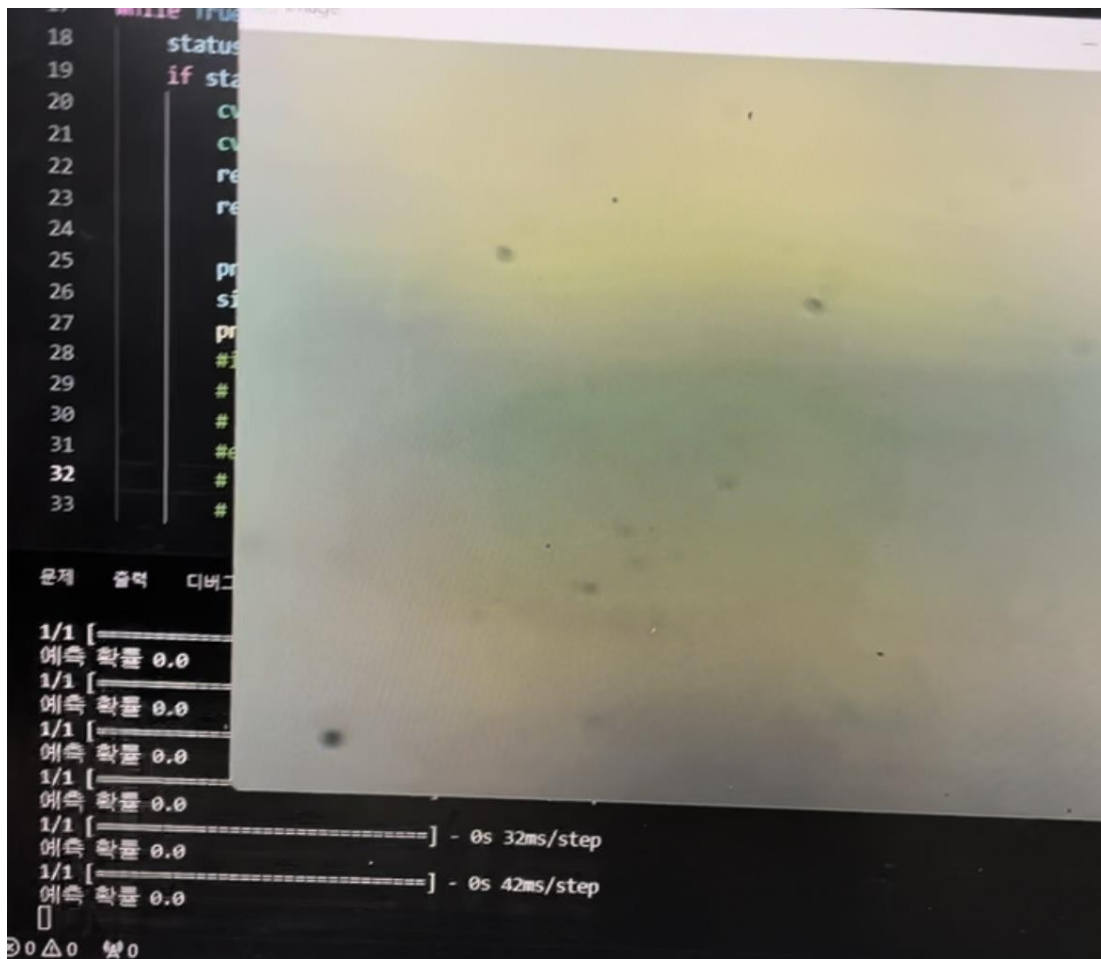
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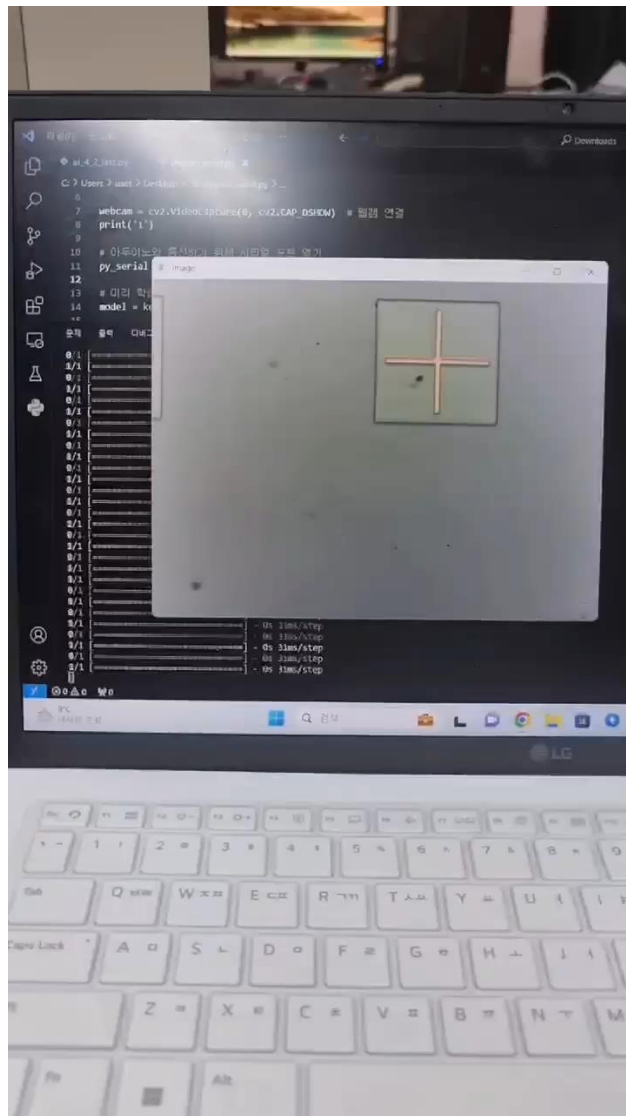
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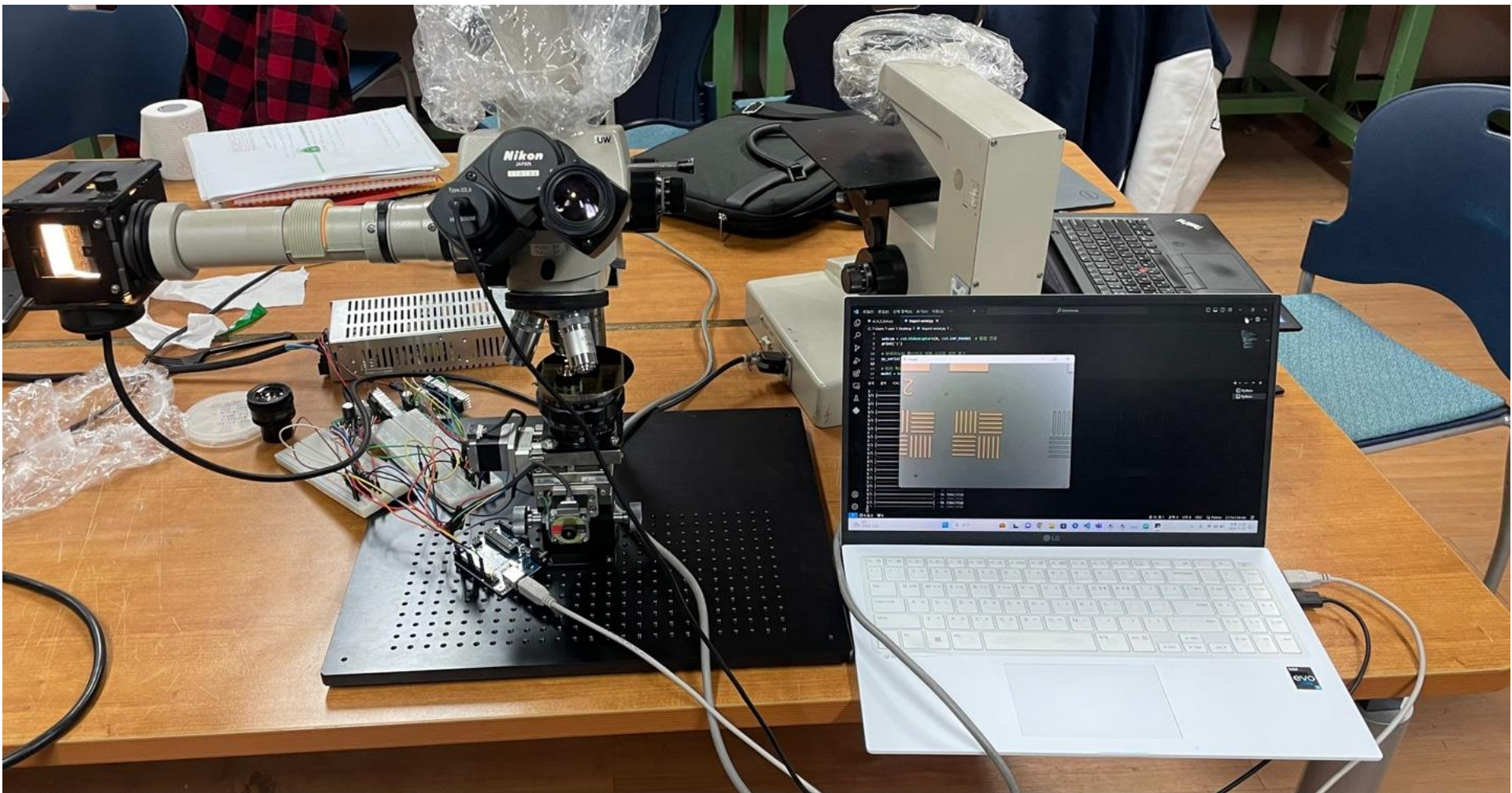




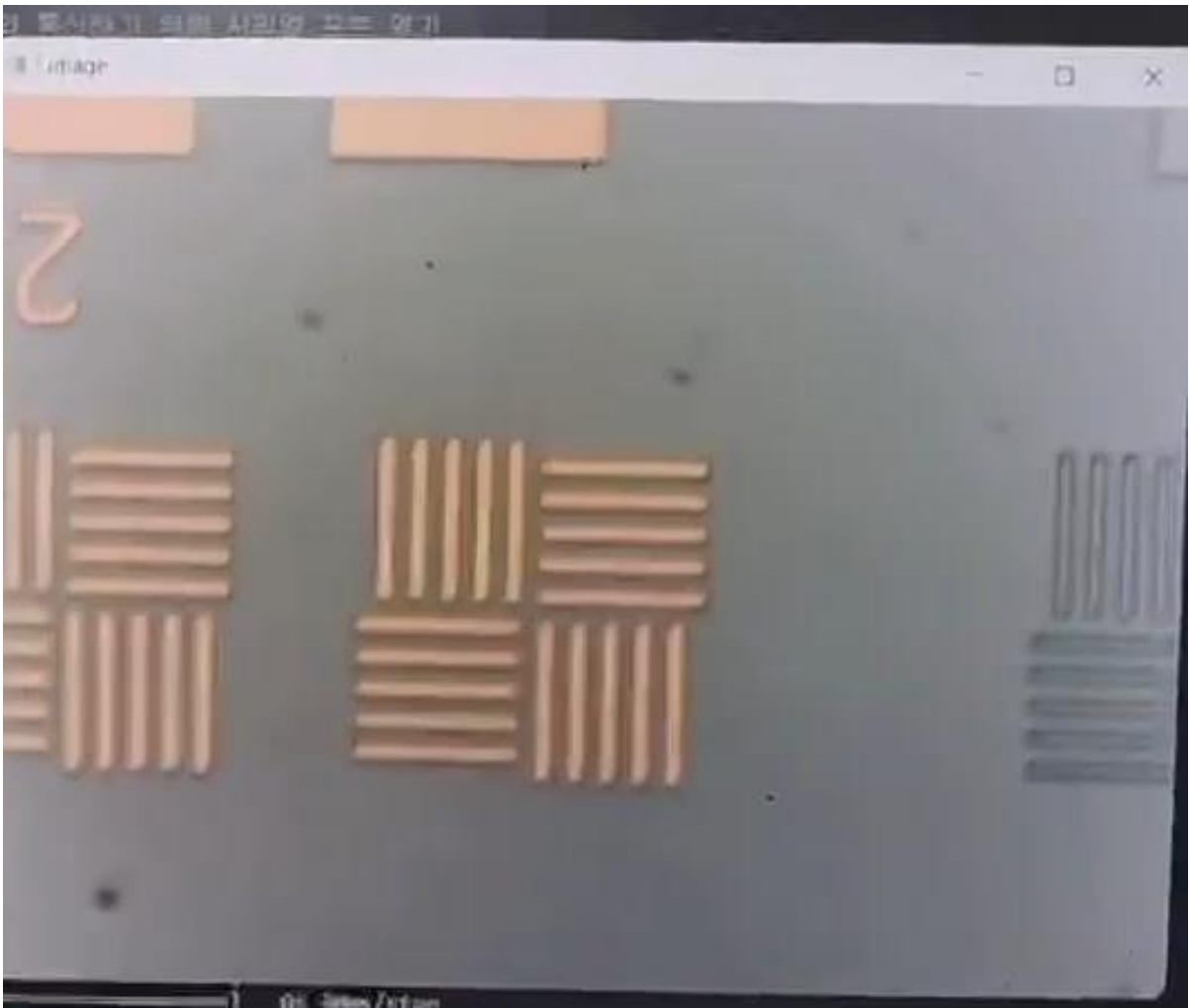
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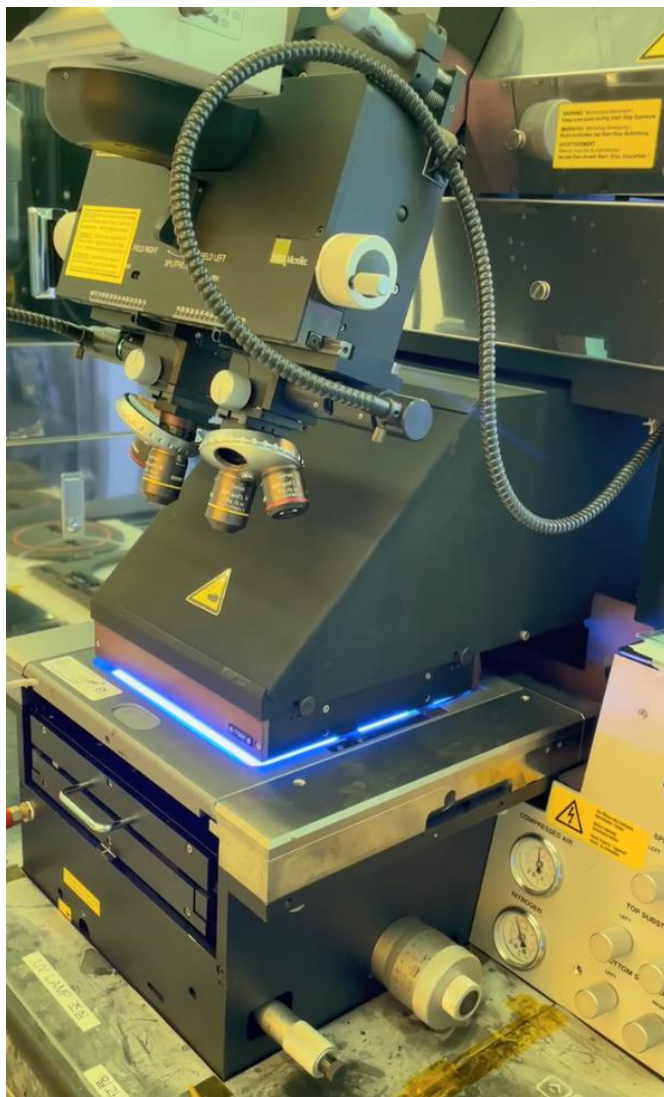
프로젝트 요약 및 성과



개선점



확장가능성



THANK YOU